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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Masaki KURASAWA et al.**

Group Art Unit: **2814**

Application Number: **09/960,398**

Examiner: **Thao X. Le**

Filed: **September 24, 2001**

Confirmation Number: **5650**

For: **CAPACITOR AND METHOD FOR FABRICATING THE SAME, AND
SEMICONDUCTOR AND METHOD FOR FABRICATING THE
SAME**

Attorney Docket Number: **011254**

Customer Number: **38834**

RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCESSING REQUESTED

BOX AF

Commissioner for Patents

P. O. Box 1450

Alexandria, VA 22313-1450

June 8, 2005

Sir:

In response to the Final Office Action dated March 17, 2005, Applicants submit the following remarks.

Please

Enter

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06/14/05